

Customer No.: 31561
Docket No.: 11583-US-PA
Application No.: 10/708,209

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Kuo, Tai-Yu et al.

Serial No.: 10/708,209

Filed: 02/17/2004

For: Thin Film Transistor Array Substrate
And Photolithography Process And
Design Of The Mask Thereof

Examiner: Doan, Theresa T

Art Unit: 2814

Docket No.: 11583-US-PA

No fee is believed to be due in connection with this amendment and response to Office Action. If, however, any fee is believed to be due, the Commissioner is authorized to charge any fees required in connection with the filing of this paper to account No. 50-2620 (order No. 11583-US-PA).

AMENDMENTS AFTER NOTICE OF ALLOWANCE UNDER 37 CFR 1.312

United States Patent and Trademark Office
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Alexandria, VA 22314

Sir:

The Notice of Allowability dated 02/10/2005, has been carefully considered. In response thereto, please enter the following amendments and consider the following remarks.

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It's OK to enter
TO
05/26/05